



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

Vance et al.

Serial No.: 10/026,329

Filed: December 19, 2001

Atty. File No.: 4851-12

For: "METHOD OF MAKING AND USING
NANOSCALE METAL"

Assistant Commissioner for Patents
Washington, D.C. 20231

) Group Art Unit: 1712

) Examiner: Metzmaier, D.

RESPONSE TO RESTRICTION
REQUIREMENT

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS
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ADDRESSED TO COMMISSIONER OF PATENTS,
WASHINGTON, D.C., 20231 ON 24 Feb 2003

SHERIDAN ROSS P.C.

BY: [Signature]

Dear Sir:

This Response is filed in reply to the Office Action mailed 4 December 2002 (Paper No. 3). A request for a two month extension of time to extend the time for response from 4 January 2003 to 4 March 2003 is being submitted herewith, along with the requisite fee. Please debit any underpayment or credit any overpayment to Deposit Account No. 19-1970.

REMARKS

The Examiner has imposed a restriction requirement under 35 U.S.C. § 121 between Claims 1- 10 (Group I) and Claims 11-21 (Group II). Applicants hereby elect examination of the Examiner's Group I, claims 1-10, without intending to abandon or to dedicate to the public any patentable subject matter.

Respectfully submitted,

SHERIDAN ROSS P.C.

By: [Signature]

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Date: 24 FEB 2003

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